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CONFIRMATION NO. 8459

SERIAL NUMBER 10/671,922	FILING or 371(c) DATE 09/24/2003 RULE	CLASS 427	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. MI22-2296		
APPLICANTS Garo J. Derderian, Boise, ID; Gurtej S. Sandhu, Boise, ID; ** CONTINUING DATA ***** <i>NONE</i> ** FOREIGN APPLICATIONS ***** <i>NONE</i> ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 12/16/2003						
Foreign Priority claimed <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No 35 USC 119(a-d) conditions met <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No Verified and Acknowledged <u>/MOHSEN AHMADI/</u> Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY ID	SHEETS DRAWINGS 4	TOTAL CLAIMS 34	INDEPENDENT CLAIMS 3
ADDRESS WELLS ST. JOHN P.S. 601 W. FIRST AVENUE, SUITE 1300 SPOKANE, WA 99201 UNITED STATES						
TITLE Atomic layer deposition methods, and methods of forming materials over semiconductor substrates						
FILING FEE RECEIVED 1002	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit			

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